

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshitaka SASAKI et al.

Application No.: Rule 53(b) Continuing Application of
U.S. Application No. 09/748,207, filed
December 27, 2000

Filed: March 2, 2004

Docket No.: 108272.01

For: THIN-FILM MAGNETIC HEAD AND METHOD OF MANUFACTURING SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

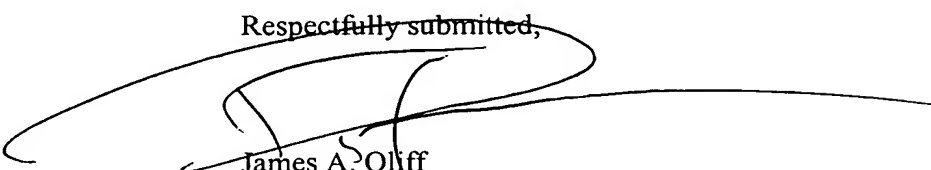
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.



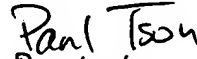
1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

- ☒ 2. The references were cited by or submitted to the Office in parent application No. 09/748,207, filed December 27, 2000, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,


James A. Oliff
Registration No. 27,075

David E. Brown
Registration No. 51,091


Registration No. 37,956

JAO:DEB/tbh

Date: March 2, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108272.01		APPLICATION NO. Rule 53(b) Continuing Application of U.S. Application No. 09/748,207	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Yoshitaka SASAKI et al.			
				FILING DATE March 2, 2004			

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	1	6,083,410	07/2000	Ikegawa et al.		
	2	6,333,841	12/2001	Sasaki		
	3	6,459,551	10/2002	Hayakawa		

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	4	JP A 4-232250	08/1992	Japan		
	5	JP A 9-91618	04/1997	Japan		
	6	JP A 11-353616	12/1999	Japan		
	7	JP A 11-39614	12/1999	Japan		
	8	WO 99/41739	08/1999	WIPO		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	
	Ericsson et al.; "Properties of Al ₂ O ₃ -films deposited on silicon by atomic layer epitaxy"; Microelectronic Engineering 36 (1997) 91-94

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: March 2, 2004